COMBINED DECLARATION AND POWER OF ATTORNEY

As a below named inventor, I hereby declare that:

My residence, post office address and citizenship are as stated below next to my name,

I believe I am the original, first and sole inventor (if only one name is listed below) or an original, first and joint inventor (if plural names are listed below) of the subject matter which is claimed and for which a patent is sought on the invention entitled FABRICATION OF DRAM AND OTHER SEMICONDUCTOR DEVICES WITH AN INSULATING FILM USING A WET RAPID THERMAL OXIDATION PROCESS, the specification of which was filed on ______ as Application Serial No. ______ and was amended on ______ is attached hereto. was filed on ___ was described and claimed in PCT International Application No. filed on _____ and as amended under PCT Article 19 on _____ I hereby state that I have reviewed and understand the contents of the above-identified specification, including the claims, as amended by any amendment referred to above. I acknowledge the duty to disclose all information I know to be material to patentability in accordance with Title 37, Code of Federal Regulations, §1.56. I hereby appoint the following attorneys and/or agents to prosecute this application and to transact all business in the Patent and Trademark Office connected therewith: Michael L. Lynch, Reg. No. 30,871; Lia M. Pappas, Reg. No. 34,095; W. Eric Webostad, Reg. No. 35,406; Charles B. Brantley II, Reg. No. 38,086; Samuel Borodach, Reg. No. 38,388; Victor Siber, Reg. No. 27149; Stephan J. Filipek, Reg. No. 33,384; John B. Pegram, Reg. No. 25,198; William J. Hone, Reg. No. 26,739; Frederick H. Rabin, Reg. No. 24,488; Richard P. Ferrara, Reg. No. 30,632; Gabriel P. Kralik, Reg. No. 34,855; Andrew T. D'Amico, Reg. No. 33,375; Andrew N. Parfomak, Reg. No. 32,431. Address all telephone calls to Samuel Borodach at telephone number 212/765-5070. Address all correspondence to Victor Siber, Fish & Richardson P.C., 45 Rockefeller Plaza, New York, NY 10111. I hereby declare that all statements made herein of my own knowledge are true and that all statements made on information and belief are believed to be true; and further that these statements were made with the knowledge that willful false statements and the like so made are punishable by fine or imprisonment, or both, under Section 1001 of Title 18 of the United States Code and that such willful false statements may jeopardize the validity of the application or any patents issued thereon. Full Name of Inventor: Ronald A. Weimer Parida Vin Date: 17 april 1999 Inventor's Signature: Residence Address: 1696 E. Victory Road, Boise, Idaho 83706 Citizen of: U.S.A. Post Office Address: 1696 E. Victory Road, Boise, Idaho 83706

COMBINED DL LARATION AND POWER OF ATLORNEY CONTINUED

Full Name of Inventor: Scott J. DeBoen	
Inventor's Signature:	Date: 4/15/99
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COMBINED DE LARATION AND POWER OF AT. JRNEY CONTINUED

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Inventor's Signature: In Sam AlShare	Date: <u>5/17/99</u>
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PATENT

Docket No.: M4065.0319/P319

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of: Ronald Weimer et al.

Serial No.: 09/296,835

Group Art Unit: 2813

Filed: April 22, 1999

Examiner: Not Yet Assigned

For: FABRICATION OF DRAM AND OTHER SEMICONDUCTOR DEVICES WITH AN INSULATING FILM USING A WET RAPID THERMAL OXIDATION PROCESS

Assistant Commissioner for Patents

Washington, D.C. 20231

POWER OF ATTORNEY BY ASSIGNEE AND CERTIFICATE BY ASSIGNEE UNDER 37 CFR § 3.73(b)

Micron Technology, Inc., Assignee of the entire right, title and interest in the above-identified application by virtue of the Assignment, a copy of which is attached hereto, hereby appoints the attorneys and agents of the firm of Dickstein, Shapiro, Morin & Oshinsky, listed as follows: Gary M. Hoffman, 26,411; Thomas J. D'Amico, 28,371; Donald A. Gregory, 28,954; James W. Brady Jr., 32,115; Jon D. Grossman, 32,699; Mark J. Thronson, 33,082; Jeremy A. Cubert, 40,399; Laurence E. Fisher, 37,131; Brian A. Lemm, 43,748; Gianni Minutoli, 41,198; Edwin Oh, P-45,319; Eric Oliver, 35,307; William E. Powell III, 39,803; Paul L. Ratcliffe, 45,290; Mark E. Strickland, 45,138 and Salvatore P. Tamburo, 45,153, and also attorneys of Micron Technology, Inc. as its

attorneys with full power of substitution to prosecute this appucation and to transact all business in the Patent and Trademark Office in connection therewith.

The Assignee certifies that the above-identified assignment has been reviewed and to the best of the Assignee's knowledge and belief, title is in the assignee.

Please direct all correspondence regarding this application to the following:

Thomas J. D'Amico
Dickstein Shapiro Morin & Oshinsky LLP
2101 L Street NW
Talankanan (202) 785 0700

Telephone: (202) 785-9700 Fax: (202) 887-0689

MICRON TECHNOLOGY, INC.

Michael L. Lynch Chief Patent Counsel Registration No. 30,871

Dated: 07/11, 2000

ASSIGNMENT



For valuable consideration, We, Ronald A. Weimer of 1696 E. Victory Road, Boise, Idaho 83706, Scott J. DeBoer of 259 E. Twin Willow, Boise, Idaho 83706, Dan Gealy of 4300 Junayo Ln, Kuna, Idaho 83634 and Husam N. Al-Shareef of 2856 W. Cherry Lane, Boise, Idaho 83704 hereby assign to Micron Technology, Inc., a Delaware corporation having a place of business at 8000 S. Federal Way, Boise, Idaho 83706-9632, and its successors and assigns (collectively hereinafter called "the Assignee"), the entire right, title and interest throughout the world in the inventions and improvements which are subject of an application for United States Patent signed by us, entitled

FABRICATION OF DRAM AND OTHER SEMICONDUCTOR DEVICES WITH AN INSULATING FILM USING A WET RAPID THERMAL OXIDATION PROCESS

filed on April 22, 1999 and assigned U.S. Serial Number 09/296 &35, and we authorize and request the attorneys appointed in said application to hereafter complete this assignment by inserting above the filing date and serial number of said application when known; this assignment including said application, any and all United States and foreign patents, utility models, and design registrations granted for any of said inventions or improvements, and the right to claim priority based on the filing date of said application under the International Convention for the Protection of Industrial Property, the Patent Cooperation Treaty, the European Patent Convention, and all other treaties of like purposes; and we authorize the Assignee to apply in all countries in our name or in its own name for patents, utility models, and design registrations and like rights of exclusion and for inventors' certificates for said inventions and improvements; and we agree for ourselves and our respective heirs, legal representatives and assigns, without further compensation to perform such lawful acts and to sign such further applications, assignments, Preliminary Statements and other lawful documents as the Assignee may reasonably request to effectuate fully this assignment.
IN WITNESS WHEREOF, I hereto set my hand and seal at
Ronald A. Weimer STATE OF:
COUNTY OF: ss.
Before me this 14th day of 1991, personally appeared Ronald A. Weimer, known to me to be the person whose name is subscribed to the foregoing Assignment, and acknowledged that he executed the same as his free act and deed for the purposes therein contained.
Sish Soman-Sailer Notary Public
My Commission Expires: 3-36-03 [Notary's Seal Here]

	Let my hand and seal at Boise, Ia. 3	,
this 15th day of April Scott J. De		.S.
STATE OF <u>IDAHO</u>	: :ss.	
COUNTY OF ADA	:	
acknowledged that he executed t	day of, 1998, personally appeared to be the person whose name is subscribed to the foregoing Assignment, a che same as his free act and deed for the purposes therein contained.	nd
[Notaty's Seat Here *	Commission Expires: 3/12/2002	
THE OF DARRIES	and	
IN WITNESS WHEREOF, I hereto	set my hand and seal at Boise, and	,
IN WITNESS WHEREOF, I hereto		,
In Witness Whereof, I hereto this day of _April	, 199 9 la	, s.
In Witness Whereof, I hereto	, 199 9 la	,
In Witness Whereof, I hereto this day of Dan Gealy	, 199 9 la	, S.

ASSIGNMENT

For valuable consideration, I, Husam N. Al-Shareef of Muraijeb, Al-Ain, United Arab Emirates, hereby assign to Micron Technology, Inc., a Delaware corporation having a place of business at 8000 S. Federal Way, Boise, Idaho 83706-9632, and its successors and assigns (collectively hereinafter called "the Assignee"), the entire right, title and interest throughout the world in the inventions and improvements which are subject of an application for United States Patent signed by me, entitled

FABRICATION OF DRAM AND OTHER SEMICONDUCTOR DEVICES WITH AN INSULATING FILM USING A WET RAPID THERMAL OXIDATION PROCESS

filed on April 22, 1999 and assigned U.S. Serial Number 09/296,835, and we authorize request the attorneys appointed in said application to hereafter complete this assignment by inserting a the filing date and serial number of said application when known; this assignment including said application, any and all United States and foreign patents, utility models, and design registrations grafor any of said inventions or improvements, and the right to claim priority based on the filing date of application under the International Convention for the Protection of Industrial Property, the Patent Cooperation Treaty, the European Patent Convention, and all other treaties of like purposes; and we authorize the Assignee to apply in all countries in my name or in its own name for patents, utility me and design registrations and like rights of exclusion and for inventors' certificates for said inventions improvements; and I agree for myself and my heirs, legal representatives and assigns, without further compensation to perform such lawful acts and to sign such further applications, assignments, Prelimi Statements and other lawful documents as the Assignee may reasonably request to effectuate fully this assignment.	anted f said odels, and r nary
In Witness Whereof, I hereto set my hand and seal at Al-Ain, United Arab Enuta	los,
this 17 day of May, 1999 Husam AlShacef Husam N. Al-Shareef	L.S.
Husam N. Al-Shareer	
Witness:	